

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	§	Atty Docket No.: TSMC2003-0551 / 24061.106
Chung-Chieh FANG	§	
	§	Customer No.: 42717
Application No.: 10/809,985	§	
	§	Examiner: Baird, Edward J.
Filing Date: March 26, 2004	§	
	§	Art Unit: 9614
Entitled: Semiconductor Manufacturing	§	
Capacity Features Exchange System	§	Confirmation No.: 9614

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION
MAILED JULY 23, 2008**

Sir:

In response to the final Office Action of July 23, 2008, entry of the following amendments and comments into the record of the above-identified application is respectfully requested. No additional fees are believed to be due in connection with this filing. Should any additional fees be required, please charge any such fees to Haynes & Boone LLP Deposit Account No. 08-1394.

I. Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

II. Remarks begin on page 5 of this paper.